IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application No.: 10/506,956 Confirmation No.: 8795 Filed: March 24, 2005

Inventor(s): Agrawal, C.M.

Title: GAS PLASMA TREATMENT

OF IMPLANTS

Examiner: Art Unit: 88888 Atty. Dkt. No:

David Naff 1657 5660-00503

CERTIFICATE OF ELECTRONIC FILING UNDER 37 C.F.R. §1.8

DATE OF DEPOSIT: January 2, 2008 I hereby certify that this correspondence is being deposited with the United States patent office using the EFS-Web Service on the date indicated above: Commissioner for Patents Alexandria, VA 22113-1450

Λe

Jackie Pitre

AMENDMENT/RESPONSE TO OFFICE ACTION MAILED JULY 2, 2007

Mail Stop: AMENDMENT

Commissioner for Patents P.O. Box 1450.

Alexandria, VA 22313-1450

Sir:

Please amend the above-captioned application as follows:

Amendments to the Specification begin on page 2 of this paper; Amendments to the Claims begin on page 3 of this paper; and Remarks begin on page 8 of this paper.